



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Hirofumi FUKUOKA et al. : Group Art Unit.: 1754
Serial No.: 09/773,677 : Examiner: JOHNSON, Edward M.
Filed: February 2, 2001 :
Title: METHOD AND APPARATUS FOR THE CONTINUOUS PRODUCTION OF
SILICON OXIDE POWDER

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

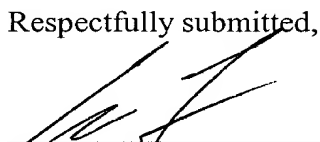
SIR:

In response to the Office Action mailed on September 16, 2003, applicants elect with traverse Group I, claims 1 and 2 drawn to a method for making silicon oxide.

The traversal is on the grounds that the Patent Office has not established that it would pose an undue burden to examine the full scope of the claimed invention.

The Commissioner is hereby authorized to charge any fees associated with this response or credit any overpayment to Deposit Account No. 13-3402.

Respectfully submitted,



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